

<b>Examiner-Initiated Interview Summary</b>	<b>Application No.</b>	<b>Applicant(s)</b>	
	10/649,507	TRAN, LUAN	
	<b>Examiner</b>	<b>Art Unit</b>	
	David S Blum	2813	

**All Participants:**

(1) David S Blum.

(2) James Beyer.

**Status of Application:** Allowed

(3) \_\_\_\_\_.

(4) \_\_\_\_\_.

**Date of Interview:** 21 October 2004

**Time:** 10:30AM

**Type of Interview:**

- ☒ Telephonic  
☐ Video Conference  
☐ Personal (Copy given to: ☐ Applicant ☐ Applicant's representative)

Exhibit Shown or Demonstrated: ☐ Yes ☐ No  
 If Yes, provide a brief description:

**Part I.**

Rejection(s) discussed:

Claims discussed:

1-44

Prior art documents discussed:

**Part II.**

SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:

*See Continuation Sheet*

**Part III.**

- ☒ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.  
☐ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.

  
 (Examiner/SPE Signature)

\_\_\_\_\_  
 (Applicant/Applicant's Representative Signature – if appropriate)

Continuation of Substance of Interview including description of the general nature of what was discussed: Discussed restriction based upon claims drawn toward a memory cell or semiconductor device with a convex plug and others toward a memory cell, semiconductor device, or computer with a memory cell having a plug free of concavities. The applicant agreed to cancel all claims toward a memory cell, device and computer with a plug free of concavities.